

Uniquely low volumetric thermal expansion of siloxane-containing polyimide copolymers

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[Introduction] Polyimides (PIs) are used as an insulating film for electronic circuit boards because of their excellent properties. Block copolyimides with poly(dimethyl siloxane)

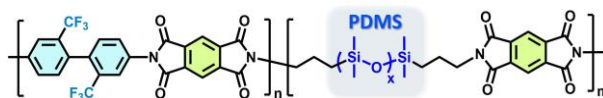


Fig. 1 Chemical structure of PI/PDMS.

(PDMS) have been developed to improve the toughness and adhesion properties of PIs. However, copolymerization with PDMS leads to a decrease in thermal stability of the dimension. Contrary, we have found that a multi-block copolymer of a fluorinated fully aromatic PI, PMDA-TFDB, and PDMS (PI/PDMS, Fig. 1) shows significantly smaller coefficient of volumetric thermal expansion (CVE) than the PMDA-TFDB homopolymer (Homo-PI). Here, we tried to clarify the mechanism of the low CVE of PI/PDMS by analyzing the structural change during the heating process.

[Experiments] PAA solutions of the precursor of PI/PDMS_x (molecular weight of PDMS block (x) = 0.8k, 1.5k, 2.9k, 4.4k, 5.5k, and 25k, volume fraction of PDMS = 12.6%), were prepared on glass plates, and cured at 400°C. Tensile tests were performed to obtain stress-strain curves. The in-plane and out-of-plane linear thermal expansion coefficients of the film, CTE_∥ and CTE_⊥, were evaluated and CVE was calculated by 2·CTE_∥ + CTE_⊥. Changes in the microphase-separated (MPS) structure of PI/PDMS on heating process were investigated by in-situ variable-temperature small-angle X-ray scattering (VT-SAXS) measurements. The weight density of the films was measured by the sink-float method, and the PDMS density in PI/PDMS was estimated from the measured density by assuming the density of PI block is same as that of the Homo-PI.

[Results and Discussion] PI/PDMS_{4.4k} shows higher breaking-elongation than that of the Homo-PI, even though each Young's modulus is comparable (Fig. 2). The CVE of the PI/PDMS decreased with increasing molecular weight (Mw) of PDMS block and smaller than that of the Homo-PI when Mw of PDMS > 4.4k (Fig. 3). TEM image of a cross section of PI/PDMS (Fig. 4) shows a MPS structure consisting of dark islands (PDMS phase) in a light gray background (PI phase). The temperature dependence of the SAXS intensity curves indicates that the electron-density difference between the PI and PDMS phases decreases with heating while maintaining their structure. The density of PDMS in PI/PDMS decreased with increasing Mw of PDMS block and became lower than that of PDMS homopolymer (0.97) when Mw > 3.0k (Fig. 5). From the above results, the low CVE of PI/PDMS would be explainable by a volume reduction on heating induced with partial mixing of both PI and PDMS block and negative thermal expansion of the excessively low-density PDMS block.

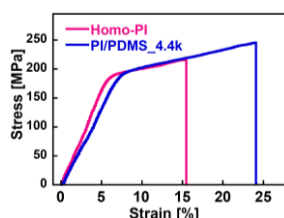


Fig. 2 Mechanical property of Homo-PI and PI/PDMS film.

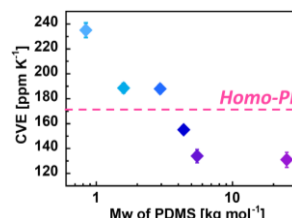


Fig. 3 Mw of PDMS versus CVE of PI/PDMS.

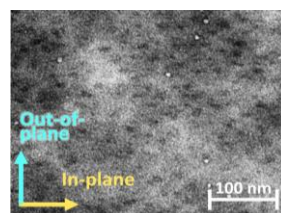


Fig. 4 TEM image of PI/PDMS observed without staining.

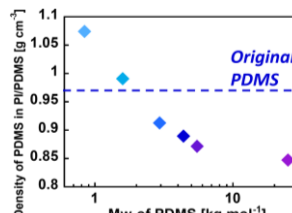


Fig. 5 Mw of PDMS versus density of PDMS in PI/PDMS.

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